



EV550720468

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. 10/734,072
Confirmation No. 8908
Filing Date December 10, 2003
Inventor Mark E. Tuttle et al.
Assignee Micron Technology, Inc.
Group Art Unit 2891
Examiner Caridad Everhart
Customer No. 021567
Attorney Docket No. MI40-369
Title: Methods for Forming Integrated Circuits Within Substrates

RESPONSE TO SEPTEMBER 8, 2005 FINAL OFFICE ACTION
ACCOMPANYING REQUEST FOR CONTINUED EXAMINATION (RCE)

To: Mail Stop RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

From: Deepak Malhotra (Tel. 509-624-4276; Fax 509-838-3424)
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AMENDMENTS

Responsive to the Final Office Action dated September 8, 2005 in this
Reissue application, Applicants amend and remark as follows. Unless otherwise
indicated, deletions are bracketed, additions are underlined. -